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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/624,252	07/24/2000	Bernd Schottker	1384.1038 (JDH)	6211

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EXAMINER

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ART UNIT

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1765

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Please find below and/or attached an Office communication concerning this application or proceeding.



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Paper Number **10**

In re Application of:
Bernd Schoettker et al.
Serial No. 09/624,252
Filed: July 24, 2000
For: METHOD FOR GROWING NITROGENOUS
SEMICONDUCTOR CRYSTAL MATERIALS

**DECISION ON
PETITION**

This is a decision on the petition, filed December 11, 2001, to correct inventorship under 37 CFR 1.48 (a). It is noted that the applicant has met the requirements of (i) a petition including statements from the person who through error were not named as inventors that the error in inventorship occurred without deceptive intention on their part; (ii) an oath or declaration by the actual inventors as required by 37 CFR 1.63; (iii) the fee set forth in 37 CFR 1.17(i); and (iv) the written consent of the assignee under 37 CFR 3.73(b).

The petition is **GRANTED**.

Ben L. Utech

Benjamin L. Utech
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